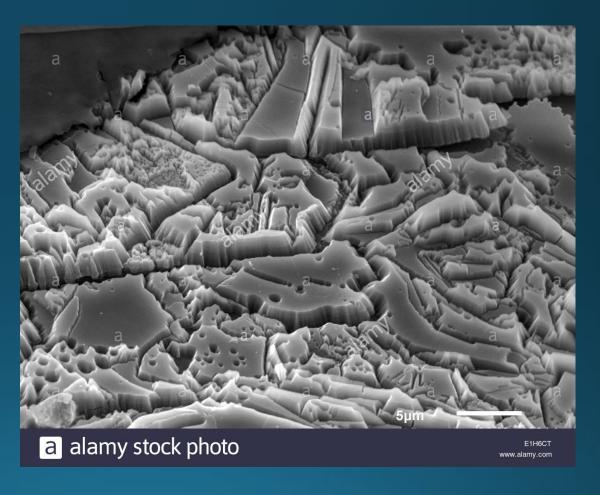
Scanning electron microscopy

Prepared by a student g.33339/1 Raziapov Timur

scanning electron microscope

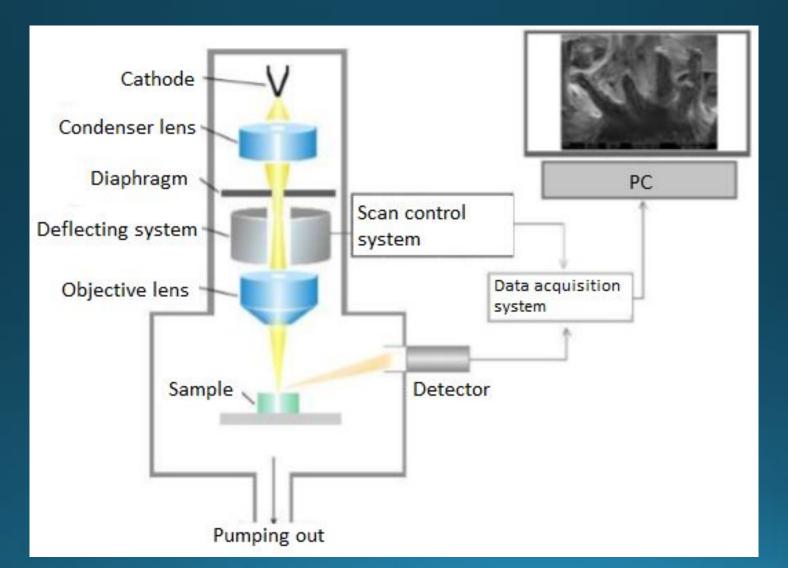


JSM-7610F Schottky Field Emission Scanning Electron Microscope

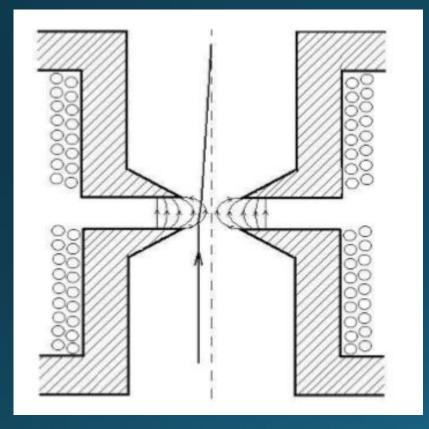


iron oxide formations with sulphur and chlorine present

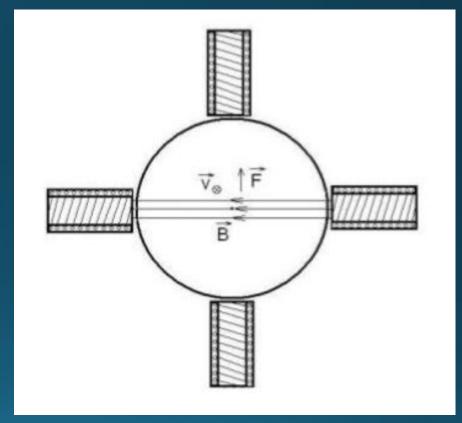
Schematic diagram SEM



Electronic optics



Magnetic lens

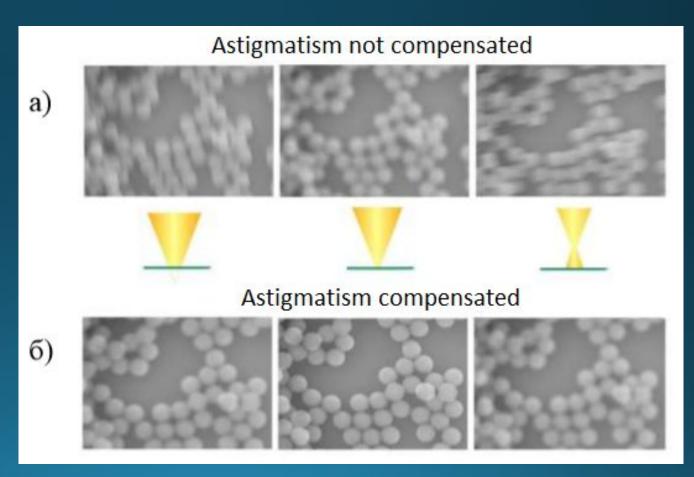


Magnetic deflection system

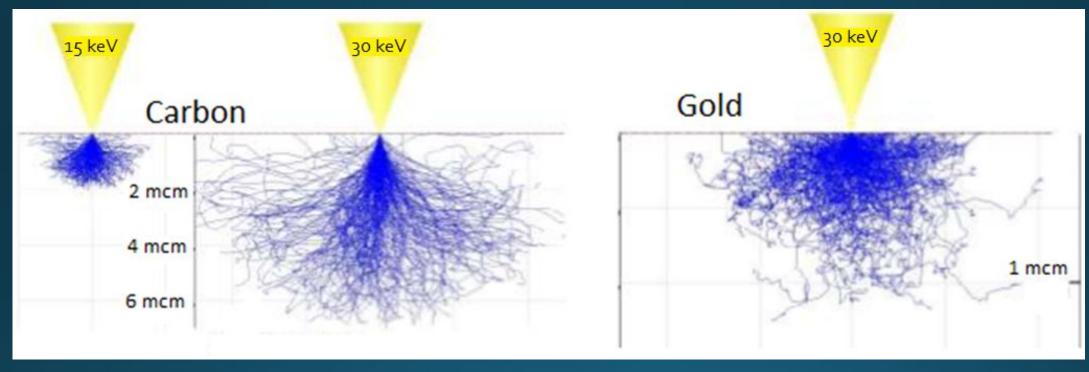
Factors that impair Magnification

- aberrations (spherical and chromatic)
- electron diffraction
- Astigmatism

Blurring the image when focusing above and below the sample in the presence of astigmatism (a) and without astigmatism (b).

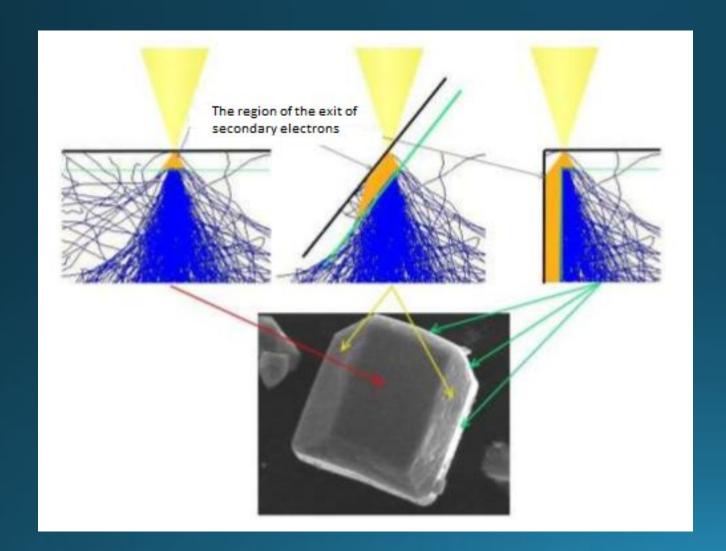


- secondary electrons
- BSE backscattered electrons
- x-rays

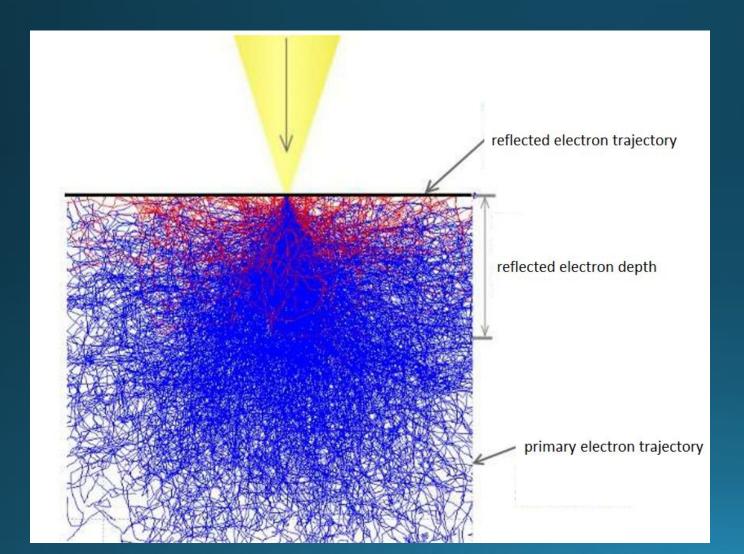


Scattering of electrons in various materials

(Hereinafter, the numerical simulation of the trajectories was performed using the MonteCarlo simulation of electron trajectory in solids software package "CASINO")

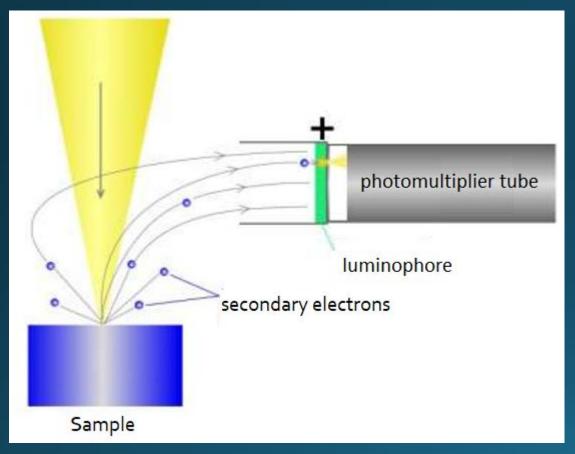


The yield of secondary electrons at different angles of incidence.



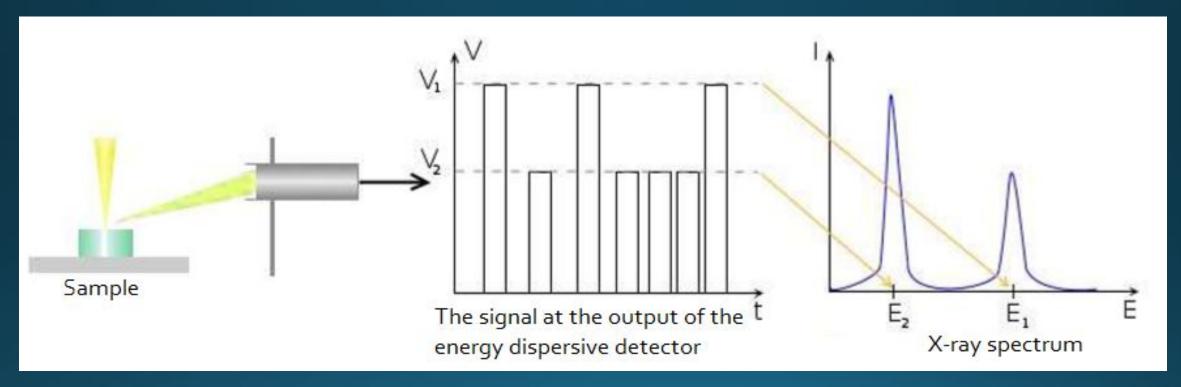
Backscattered (reflected) electrons

Detector electrons



Detection of secondary electrons.

Detector electrons



Energy Dispersive X-ray Detector

